

Notice of References Cited	Application/Control No. 10/561,907	Applicant(s)/Patent Under Reexamination YASHIRO ET AL.	
	Examiner Amanda C. Walke	Art Unit 1752	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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	N	JP 10104835 A	04-1998	Japan	HATTORI et al.	
	O					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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